



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT application of)
Koichiro TANAKA)
Serial No. 10/827,402) Group Art Unit: 2891
Filed: April 20, 2004) Examiner: Christian Wilson
For: BEAM IRRADIATION APPARATUS, BEAM)
IRRADIATION METHOD, AND METHOD FOR)
MANUFACTURING THIN FILM TRANSISTOR)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with
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REQUEST FOR STATUS

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the above-identified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,


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